



#8 EDT/ RESPONSE
5/27/03
PATENT Mullen

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

Katrina MIKHAYLICHENKO et al.

Application No. 10/033,644

Filed: December 27, 2001

For: METHOD FOR POST-ETCH AND STRIP
RESIDUE REMOVAL ON CORAL FILMS

Group Art Unit: 2823

Examiner: Nguyen, Khiem D

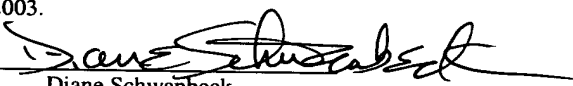
Atty. Docket: LAM2P316

Date: May 16, 2003

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to: Commissioner for Patents, Alexandria, VA 22313-1450 on May 16, 2003.

Signed:


Diane Schwanbeck

RESPONSE TO OFFICE ACTION

Commissioner for Patents
Alexandria, VA 22313-1450

Sir:

This paper is in response to the Office Action dated January 16, 2003, the shortened period for response extends to May 16, 2003 with a one month extension. Please enter the remarks as follows:

Remarks begin on page 2 of this paper.

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